

Publikationen

(2017): Parametrization of a Subaperture Polishing Tool - Analysis of the Path Tests. In: Optical Fabrication and Testing part of Optical Design and Fabrication: 9-13 July 2017, Denver, Colorado, United States, Washington, D.C., USA.

(2017): Polishing tool and the resulting TIF for three variable machine parameters as input for the removal simulation. In: Proceedings of SPIE 10326 (Fourth European Seminar on Precision Optics Manufacturing, 1032601 [April 4th-5th 2017, Teisnach]). DOI: 10.1117/12.2267415.

(2016): Hexapod as primary kinematic system for applications in the optic industry. In: Proceedings of SPIE 10009 (Third European Seminar on Precision Optics Manufacturing, 100090Y [April 12th 2016, Teisnach]). DOI: 10.1117/12.2235400.